

**Notice of References Cited**

Application/Control No.

09/781,628

Applicant(s)/Patent Under

Reexamination

MURSCHALL ET AL.

Examiner

Vivian Chen

Art Unit

1773

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**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-6,641,924	11-2003	Peiffer et al.	428/480
B	US-6,635,340	10-2003	Peiffer et al.	428/308.4
C	US-6,627,695	09-2003	Murschall et al.	524/513
D	US-6,326,431	12-2001	Peiffer et al.	525/177
E	US-2003/0180560	09-2003	Peiffer et al.	428/480
F	US-2003/0170479	09-2003	Peiffer et al.	428/515
G	US-2003/0170476	09-2003	Murschall et al.	428/483
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	
V	
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